Docket No.

289855US0PCT

IAP15 Rec'd PCT/PTO 21 APR 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Laurent LABROUSSE, et al.

SERIAL NO: New U.S PCT Application Based on PCT/FR04/50532

GAU:

FILED:

Herewith

EXAMINER:

FOR:

SUBSTRATE, IN PARTICULAR GLASS SUBSTRATE, SUPPORTING AT LEAST ONE STACK OF A

PHOTOCATALYTIC LAYER AND A SUBLAYER FOR THE HETEROEPITAXIAL GROWTH OF SAID

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Applicant(s) wish to disclose the following information.

REFERENCES

The applicant(s) wish to make of record the references cited in the International Search Report and listed on the
attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of
relevancy or any readily available English translations of pertinent portions of any non-English language
references.

A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be
related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies
of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the
attached PTO form 1449.

☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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SHEET 1 OF 1

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 289855USOPCT		SETIMO 576724 New U.S PCT Application							
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LIST OF REFERENCES CITED BY APPLICANT				APPLICANT									
				Laurent LABROUSSE, et al.									
				FILING DATE		GROUP							
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U.S. PATENT DOCUMENTS													
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS		NG DATE PROPRIATE					
	AA	2002/0045073	4/18/2002	FINLEY, James J. et al.									
	AB												
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		OTHER RE	FERENCES (Including Author, Title, Date, Pertinen	t Pages, e	tc.)							
		TAKAHASHI, T.et al.,"	Photocatalytic	Properties of TiO2/WO3 bilayers deposit	ted by reac	tive sputte	ring", Jou	rnal of Vacuum					
	TAKAHASHI, T.et al.,"Photocatalytic Properties of TiO2/WO3 bilayers deposited by reactive sputtering", Journal of Vacuum Science and Technology, Vol. 21, No 4, Pages 1409-1413, 2003.												
	OKUDERA, H. et al., "Fabrication of silica-anatase multilayer coating on a K-CA-Zn-Si glass substrate", Thin Solid Films, Vol. 441, Pages 50-55, 2003.												
	AY												
AZ Additional References sheet(s)							neet(s) attached						
Examiner			-		Examiner Date Considered								
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.													